



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Dapeng Wang

Serial No.: 10/729,112

Filed: December 5, 2003

For: DEFORMABLE PAD FOR
CHEMICAL MECHANICAL POLISHING

Confirmation No.: 3169

Examiner: R. Rose

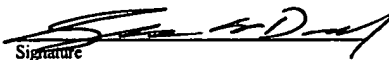
Group Art Unit: 3723

Attorney Docket No.: 2269-3579.2US
(98-0062.02/US)

CERTIFICATE OF MAILING

I hereby certify that this correspondence along with any attachments referred to or identified as being attached or enclosed is being deposited with the United States Postal Service as First Class Mail on the date of deposit shown below with sufficient postage and in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

December 23, 2005
Date


Signature

Shawnee L. MacDonald
Name (Type/Print)

AMENDMENT UNDER 37 C.F.R. §1.116

Mail Stop AF
Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

*Entry
approved
RR 1/24/06*

Sir:

The following amendments and remarks are filed in response to the Examiner's remarks in the Final Office Action mailed November 15, 2005, the three-month shortened statutory period for response to which expires on February 15, 2006. This response is submitted on or before two months from the mailing date of the Final Office Action.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 9 of this paper.